



Docket No.
90065.001020/17732.8011.00

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

Applicant	:	Martin E. Kordesch, et al.)	Examiner:
)	Chris C. Chu
Serial No.	:	09/682,151)	
Filed	:	27 July 2001)	Art Unit:
For	:	CONTACT METHOD FOR THIN SILICON CARBIDE EPITAXIAL LAYER AND SEMICONDUCTOR DEVICES FORMED BY THOSE METHODS)	2815
)	
)	
)	

Assistant Commissioner for Patents
Washington, DC 20231

TRANSMITTAL LETTER

In response to the office action mailed January 2, 2003, Applicants hereby submit the attached supplemental Declaration in connection with the above-referenced patent application.

Respectfully submitted,


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Reg. No. 26,730

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CERTIFICATE OF MAILING BY FIRST CLASS MAIL (37 CFR 1.8)

Applicant(s): Martin E. Kordesch, et al.

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Chris C. ChuGroup Art Unit
2815Invention: CONTACT METHOD FOR THIN SILICON CARBIDE EPITAXIAL LAYER AND SEMICONDUCTOR
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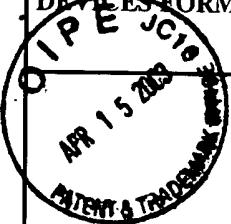
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